	1.7			
LIST OF PATENTS AND PUBLICATIONS	Atty Docket AMDSP0499US	Serial No. 09/824,933		
FOR APPLICANT'S  THE PRIMATION DISCLOSURE STATEMENT	Applicant: Lin			
(Use several sheets if necessary)	Filing Dat April 3, 2001	Group Not yet known		

**U.S. PATENT DOCUMENTS** 

Examiner Initial	Document Number	Date	Name	Class	Sub- class	Filing Date if Appropriate
K.N.	3,936,858	02/03/76	Seeds et al.			
K.N.	4,498,227	02/12/85	Howell et al.			
K.N.	5,194,395	03/16/93	Wada			
K,N.	5,244,819	09/14/93	Yue			
K.N.	5,272,104	12/21/93	Schrantz et al.			
K,N.	5,443,661	08/22/95	Oguro et al.			
K.N.	5,453,153	09/26/95	Fan et al.		,	
K.N.	5,501,993	03/26/96	Borland			
KN.	5,646,053	07/08/97	Schepis et al.			

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
K.N.	Wolf et al.; "Silicon Processing for the VLSI Era"; Crystalline Defects, Thermal Processing and Gettering; Basic Gettering Principles; Volume 1: Process Technology; pgs. 63-70.
Kn.	Dziesiatv et al.; "Improved SI-EPI-Wafers by Buried Damage Layer for Extrinsic Gettering; pgs. 292-296.
K.N	IBM Technical Disclosure Bulletin; "Gettering Technique and Structure; May 1975.
K.N.	Wong et al.; "Nanoscale CMOS"; Proceedings of the IEE, Vol. 87, No. 4; April 1999; pgs. 537-570.

**EXAMINER** 

EXAMINER:

**DATE CONSIDERED** 

Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

C:\132\Adams-Tom\Client Files\AMD\448\ids.wpd (IDS\1449.FRM) (2/97)



<del></del>		DIICCI
Form PTO-1449 (Modified)  LIST OF PATENTS AND PUBLICAT	Atty Docket No. AMDSP0448US	Serial No. 09/824,933
FOR APPLICANT'S INFORMATION DISCLOSURE STAT	Applicant: Lin	
(Use several sheets if necessary)	Filing Date	Group
	April 3, 2001	Not yet known

Document Number   Date   Name   Class   Subclass   Filing Date   Name   Class   Subclass   Filing Date   Name   Class   Subclass   Filing Date   Filing Da	
K.N.   5,753,560   05/19/98   Hong et al.	e if
KN   5,773,152   06/30/98   Okonogi   Kル   5,795,809   08/18/98   Gardner et al.	, ———
ドル 5,795,809 08/18/98 Gardner et al.  ドル 5,807,771 09/15/98 Vu et al.  ドル 5,818,085 10/06/98 Hsu et al.  ドル 5,882,990 03/16/99 DeBusk et al.  ドル 5,899,732 05/04/99 Gardner et al.  ドル 5,926,727 07/20/99 Stevens et al.  ドル 5,929,508 07/27/99 Delgado et al.  ドル 5,965,917 10/12/99 Maszara et al.  ドル 5,976,956 11/02/99 Gardner et al.  ドル 6,001,711 12/14/99 Hashimoto	
KN       5,807,771       09/15/98       Vu et al.         KN       5,818,085       10/06/98       Hsu et al.         KN       5,882,990       03/16/99       DeBusk et al.         KN       5,899,732       05/04/99       Gardner et al.         KN       5,926,727       07/20/99       Stevens et al.         KN       5,929,508       07/27/99       Delgado et al.         KN       5,965,917       10/12/99       Maszara et al.         KN       5,976,956       11/02/99       Gardner et al.         KN       6,001,711       12/14/99       Hashimoto	
大心	
大小	
「大い 5,899,732 05/04/99 Gardner et al. 大い 5,926,727 07/20/99 Stevens et al. 大い 5,929,508 07/27/99 Delgado et al. 大い 5,965,917 10/12/99 Maszara et al. 大い 5,976,956 11/02/99 Gardner et al. 大い 6,001,711 12/14/99 Hashimoto	
KN       5,926,727       07/20/99       Stevens et al.         KD       5,929,508       07/27/99       Delgado et al.         KD       5,965,917       10/12/99       Maszara et al.         KD       5,976,956       11/02/99       Gardner et al.         KD       6,001,711       12/14/99       Hashimoto	
「大い 5,929,508 07/27/99 Delgado et al.	
大八 5,965,917	
KN 6,001,711 12/14/99 Hashimoto	
COLO OSO	$\dashv$
V.) 6 010 950 04/04/05 01	-∦
KN 6,010,950 01/04/00 Okumura et al.	-
KN 6,013,584 01/11/00 M'Saad	
KN 6,022,793 02/08/00 Wijaranakula et al.	_
Kr 6,024,888 02/15/00 Watanabe et al.	$-\parallel$
KN 6,083,324 07/04/00 Henley et al.	$\dashv$
KN 6,093,624 07/25/00 Letavic et al.	$-\parallel$
KN 6,100,202 08/08/00 Lin et al.	$\dashv$
Krv 6,114,223 09/05/00 Gonzalez et al.	-
KN 6,133,123 10/17/00 Gonzalez	$-\parallel$

		,	•
EXAMINER	Knemmanyen	DATE CONSIDERED	7
EXAMINER:	Initial if reference considered, whether or not citation is in not considered. Include copy of this form with next common terms of the considered of the considered.	conformance with MPEP 609; Draw line through citation if not in conformance an unleation to applicant.	and

Form PTO-1449 (Modified)	Atty Docket No.	Serial No.
LIST OF PATENTS AND PUBLICATIONS	F0556	09/824,933
FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant: Ming-Ren L	in
(Use several sheets if necessary)	Filing Date	Group
(030 30Veral Sheets II Hecessary)	04/03/01	2823

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub- class	Filing Date if Appropriate
			<u> </u>			

## FOREIGN PATENT DOCUMENTS

Examiner	Document Number	Date	Country	Class	Sub- class	Translati	on
Initial			:		Class	Yes	No
K.N.	99/26291	27/05/99	wo				
К.и.	63-271941	09/11/88	JP			Abstr	act
KN.	2000-323484	24/11/00	JP			Abstr	act

## OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.

EXAMINER	DATE CONSIDERED
Theman, and	12/17/02

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Drew line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

## Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

C:\share\132\Adams-Tom\Client Files\AMD\P448-F0556\IDS.4.wpd (IDS1449.FRM) (2/97)